

IAP20 Rec'd PCT/PTO 27 JAN 2006
PATENT**IN THE UNITED STATES PATENT OFFICE**

Serial No.: Not yet assigned

Filed: Herewith

For: **DEVICE AND METHOD FOR
ELECTROLYTICALLY TREATING
ELECTRICALLY INSULATED STRUCTURES**

Inventor(s): Michael Guggemos and Franz Kohnle

Based on: PCT/EP2004/009436, dated August 19, 2004

Priority: DE 10342512.8, dated September 12, 2003

Atty Doc. No.: 366-05

INFORMATION DISCLOSURE STATEMENT

*Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450*

Sir:

In the interest of full disclosure, the following items are herewith identified in Form PTO-1449 and a copy of the same is hereby provided, for the convenience of the U.S. Patent and Trademark Office.

This Information Disclosure Statement is being filed before the mailing date of the first official action.

U.S. PATENT DOCUMENTS

(AA) 4,560,445, dated December 24, 1985.

(AB) 5,188,720, dated February 23, 1993.

(AC) 5,425,862, dated June 20, 1995

(AD) 6,071,400, dated June 6, 2000.

IAP20 REC'D 5 FEB 2010 27 JAN 2006
U.S. PATENT APPLICATION PUBLICATIONS

(AE) 6,309,517 B1, dated October 10, 2001.

FOREIGN PATENT DOCUMENTS

(AF) DE 100 43 814 C1, dated April 11, 2002. Relevance was cited a category "Y" in the International Search Report.

(AG) DE 100 65 643 C2, dated March 20, 2003. Relevance is cited on page two (2) of the application.

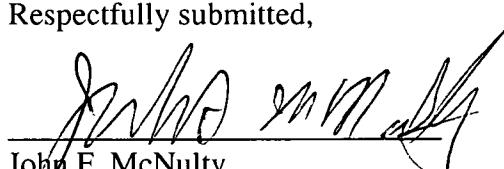
(AH) DE 100 65 649 A1, dated July 11, 2002. Relevance is cited on page three (3) of the application.

(AI) DE 199 51 325 A1, dated May 10, 2001. Relevance is cited as a category "A" in the International Search Report, enclosed herewith.

(AJ) DE 199 51 325 C2, dated June 26, 2003. Relevance is cited on page two (2) of the application.

(AK) WO 03/038158 A2, dated May 8, 2003. Relevance is cited on page two (2) of the application.

Respectfully submitted,


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Receipt date: 01/27/2006

Docket Number (Optional)

366-05

Application Number

GALL 1795
10756827

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Applicant(s)

Michael Guggemos and Franz Kohnle

Filing Date

IAP20 Rec'd PC 10 27 JAN 2006

Group Art Unit

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	4,560,445	12-24-1985	Hoover et al.			
	AB	5,188,720	02-23-1993	Colin et al.			
	AC	5,425,862	06-20-1995	Hartmann et al.			
	AD	6,071,400	06-06-2000	Shroder et al.			

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AE	6,309,517 B1	10-30-2001	Condra et al.			

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
AF	DE 100 43 814 C1	4-11-2002	GERMANY				
AG	DE 100 65 643 C2	3-20-2003	GERMANY				
AH	DE 100 65 649 A1	7-11-2002	GERMANY				
AI	DE 199 51 325 A1	5-10-2001	GERMANY				
AJ	DE 199 51 325 C2	6-26-2003	GERMANY				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Receipt date: 01/27/2006

Docket Number (Optional)

366-05

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Application Number
107566227 1795

Applicant(s)

Michael Guenzen and Franz Kohnle

Filing Date

JAN 2006
05 01 06 Group A Unit 7 JAN 2006

Herewith

NA

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
AK	WO 03/038158 A2	05-08-2003	INTERNATIONAL				

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

EXAMINER

/Luan Van/ (06/10/2009)

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.